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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Hendrikus Petru VAN DER LAAK, et al.

SERIAL NO.: NEW U.S. PCT APPLICATION

FILED: HERewith

INTERNATIONAL APPLICATION NO.: PCT/NL04/00922

INTERNATIONAL FILING DATE: December 29, 2004

FOR: METHOD, DEVICE AND DIFFRACTION GRATING FOR SEPARATING
SEMICONDUCTOR ELEMENTS FORMED ON A SUBSTRATE BY ALTERING SAID
DIFFRACTION GRATING

REQUEST FOR PRIORITY UNDER 35 U.S.C. 119
AND THE INTERNATIONAL CONVENTION

Commissioner for Patents
Alexandria, Virginia 22313

Sir:

In the matter of the above-identified application for patent, notice is hereby given that
the applicant claims as priority:

COUNTRY
EPC

APPLICATION NO
03079210.5

DAY/MONTH/YEAR
30 December 2003

Certified copies of the corresponding Convention application(s) were submitted to the
International Bureau in PCT Application No. PCT/NL04/00922.

Respectfully submitted,
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